

E UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

10/721,719

: Confirmation No.:

5752

Applicant Filed

Dingjun Wu

11/25/2003

For

METHOD FOR CLEANING DEPOSITION CHAMBERS FOR HIGH

DIELECTRIC CONSTANT MATERIALS

Art Unit

3749

Examiner

Kenneth Rinehart

Docket No.

06469 USA

Customer No.

23543

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

CERTIFICATE OF MAILING I CERTIFY THAT THIS PAPER (ALONG WITH ANY PAPER REFERRED TO AS BEING ATTACHED OR ENCLOSED) IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE WITH SUFFICIENT POSTAGE AS FIRST CLASS MAIL IN AN **ENVELOPE ADDRESSED TO:** COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450 2005 Date Rosaleen P. Morris-Oskanian Signature of person mailing paper

Amendment and Response to Final Office Action

Sir:

Enclosed herewith is an amendment and response to the Office Action mailed 8 April 2005. Please amend the above-identified application as follows:

	Amendments to the Specification begin on page	of this paper.
Ø	Amendments to the Claims are reflected in the listing of	of claims which

claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page of this paper and include an attached replacement sheet(s).

П Amendments to the Abstract are on page of this paper. A clean version of

the Abstract is on page of this paper.

 \boxtimes Remarks/Arguments begin on page 7 of this paper.